



Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No. MODEP001 Application No.: 10/665,980 Inventor MIDDLEBROOKS, et al Group unassigned 2128 Filing Date September 19, 2003
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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	L							
	M							
	N							
	O							
	P							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
RF	R	Middlebrooks, Scott A., "Optimal Model-Predictive Control of Overlay Lithography Implemented in an ASIC Fab" Proceedings of SPIE, Microlithography 2003, 5044-2
RF	S	Muske, Kenneth Robert, "Linear Model Predictive Control of Chemical Processes" University of Texas at Austin, May 1995.
	T	
Examiner <u>RUSSELL FREID</u>		Date Considered <u>30-SEP-05</u>

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.